In re Application of:



Docket No. 03500.012395.1

500.012395.1

YOSHIHIKO FUKUMOTO

Application No.: 09/429,530

Filed: October 28, 1999

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

Examiner: V. Perez Ramos

Group Art Unit: 1765

Date: May 22, 2002

COMMISSIONER FOR PATENTS

The fee has been calculated as shown below

Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

MAY 2 8 2002

No additional fee is required.

CLAIMS AS AMENDED							
•	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	34	MINUS	34	= 0	x \$9 \$18	.00	
INDEP. CLAIMS	2	MINUS	3	= 0	x \$42 \$84	.00	
Fee for Multiple Dependent claims \$140°/\$280						\$280.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$280.00	

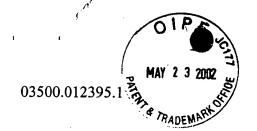
	°Verified Statement claiming small entity status is enclosed, if not filed previously.				
X	A check in the amount of \$280.00 is enclosed.				
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.				

X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.				
	A check in the amount of \$ to cover the fee for a month extension is enclosed.				
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.				
X.	Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.				
	Respectfully submitted,				
	Attorney for Applicant				
	Registration No. 32622				
FITZ	PATRICK, CELLA, HARPER & SCINTO				

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
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## PATENT APPLICATION

## #19/8 Ma 5/28/02

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
YOSHIHIKO FUKUMOTO	: Examiner: V. Perez Ramos
Application No.: 09/429,530	: Group Art Unit: 1765 )
Filed: October 28, 1999	: )
For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE	) : May 22, 2002
Commissioner for Patents	

Washington, D.C. 20231

**PRELIMINARY AMENDMENT** 

RECEIVED MAY 2 8 2002 TC 1700

Sir:

Prior to examination, please amend the above-identified Continued Prosecution Application (CPA), as follows:

## IN THE CLAIMS:

Please cancel Claims 21 to 24, 28, 29 and 33 to \$4 without prejudice or disclaimer of the subject matter presented therein and without conceding the correctness of their rejection. Please amend Claims 11, 12, 25 and 27 and add new Claims 45 to 54 as follows. A marked-up copy of the amended claims, showing the changes made thereto, is attached. Note that all claims currently pending in the application, including those not currently being amended, have been reproduced below for the Examiner's convenience.